

## ABSTRACT OF THE DISCLOSURE

An exposure mask which is capable of reducing non-uniformity in display by a liquid crystal display device.

5 A mask pattern having pattern-forming portions and shield portions mosaically arranged therein is formed in one end portion of an exposure mask, and a mask pattern having pattern-forming portions and shield portions arranged in a manner complementary to the first-mentioned mask pattern  
10 is formed the other-end portion of the exposure mask. Further, the exposure mask is formed such that areas between vertically or laterally adjacent ones of the shield portions in mosaic areas where the pattern-forming portions and the shield portions are mosaically arranged  
15 are also shielded.